

Search Notes

Application/Control No.

10/698,486

Examiner

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Applicant(s)/Patent under
Reexamination

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Art Unit

2871

SEARCHED

Class	Subclass	Date	Examiner
349	149	3/7/2005	DC
349	150	3/7/2005	DC
349	151	3/7/2005	DC
349	152	3/7/2005	DC

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
same	same	2/6/2006	DC

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST search report	3/7/2005	DC
EAST search report	2/6/2006	DC